



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Katsuto TANAHASHI et al.**

Group Art Unit: **3663**

Application Number: **10/743,793**

Examiner: **Johannes P. Mondt**

Filed: **December 24, 2003**

Confirmation Number: **9788**

For: **SEMICONDUCTOR SUBSTRATE AND MANUFACTURING  
METHOD THEREOF**

Attorney Docket Number: **032206**  
Customer Number: **38834**

**RESPONSE UNDER 37 C.F.R. § 1.111**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

May 3, 2006

Sir:

In response to the Office Action dated January 4, 2006, the response date of which having been extended by one month to May 4, 2006, Applicants submit the following remarks, which begin on page 2 of this paper.